

# Chapter 2

## Devices and Layouts

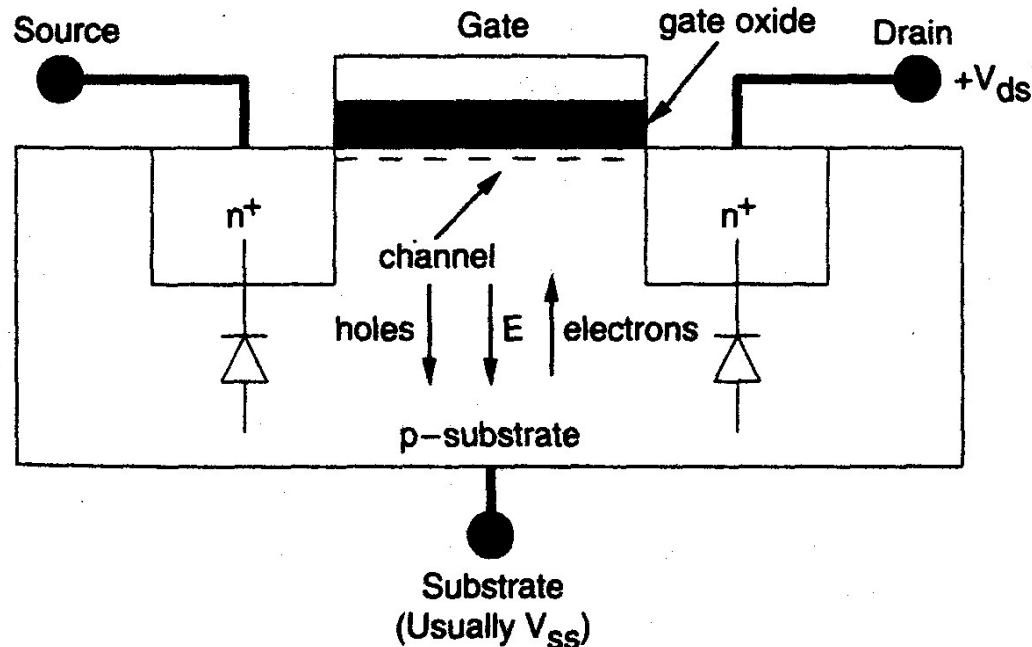


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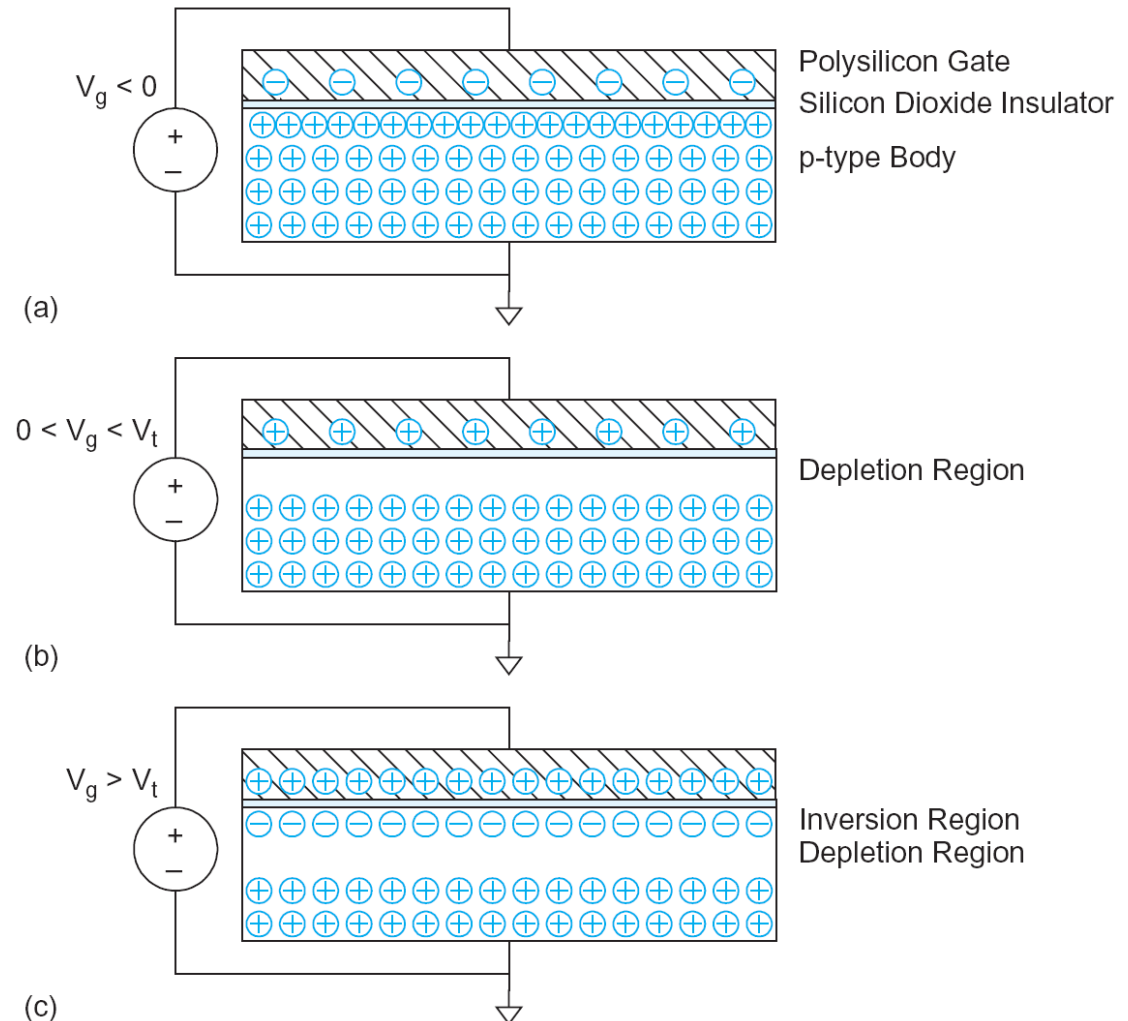
# NMOS Enhancement Transistor

- Physical structure of an NMOS transistor.
- Gate, Source, Drain, Substrate, Channel.
- [https://www.youtube.com/watch?v=tz62t-q\\_KEc](https://www.youtube.com/watch?v=tz62t-q_KEc)



# MOS Junction Operating Modes

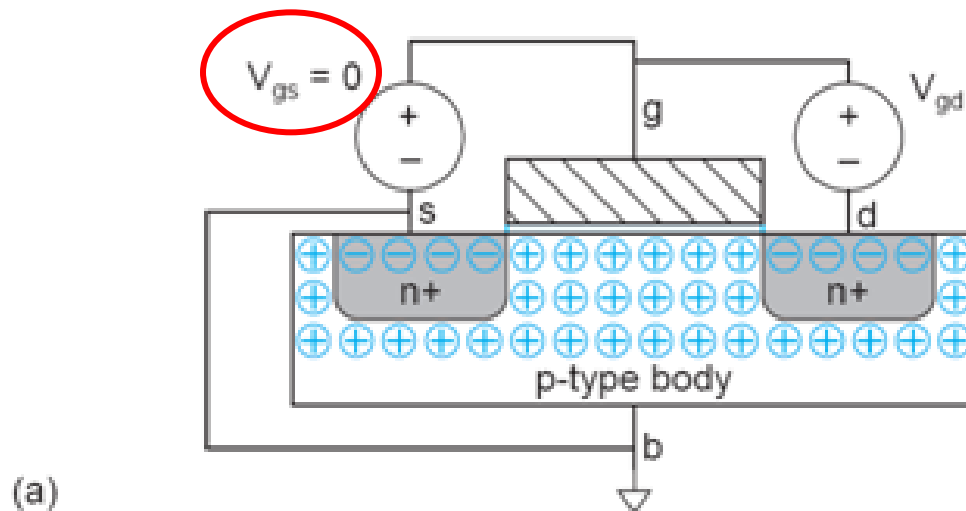
- Different  $V_{gs}$  -- accumulation, depletion, inversion (weak and strong)



**FIGURE 2.2** MOS structure demonstrating (a) accumulation, (b) depletion, and (c) inversion

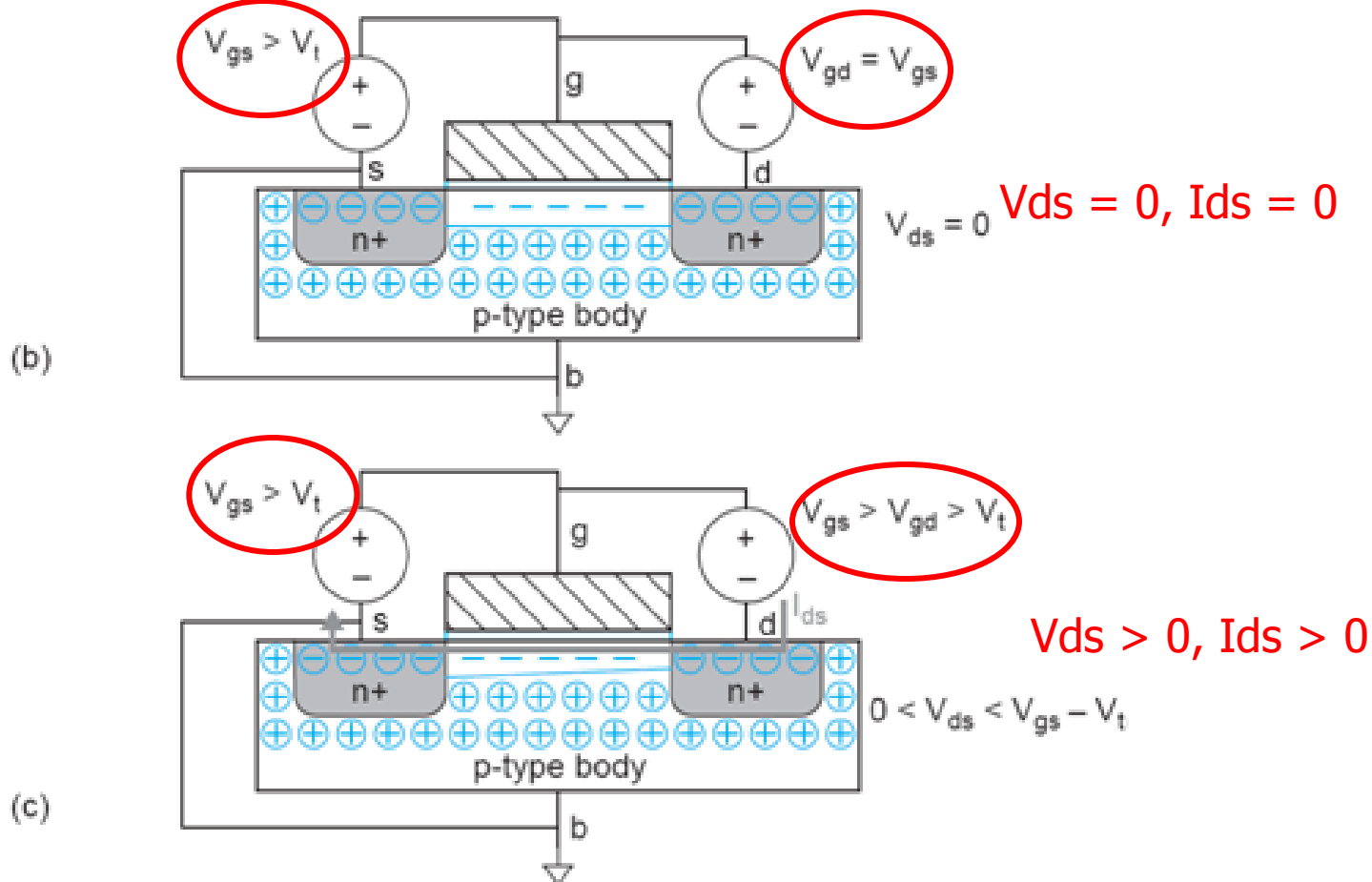
# MOS Operating Regions

- Different  $V_{gs}$  and  $V_{ds}$  -- Cutoff, linear, saturation
- Cutoff region: No channel,  $I_{ds} = 0$



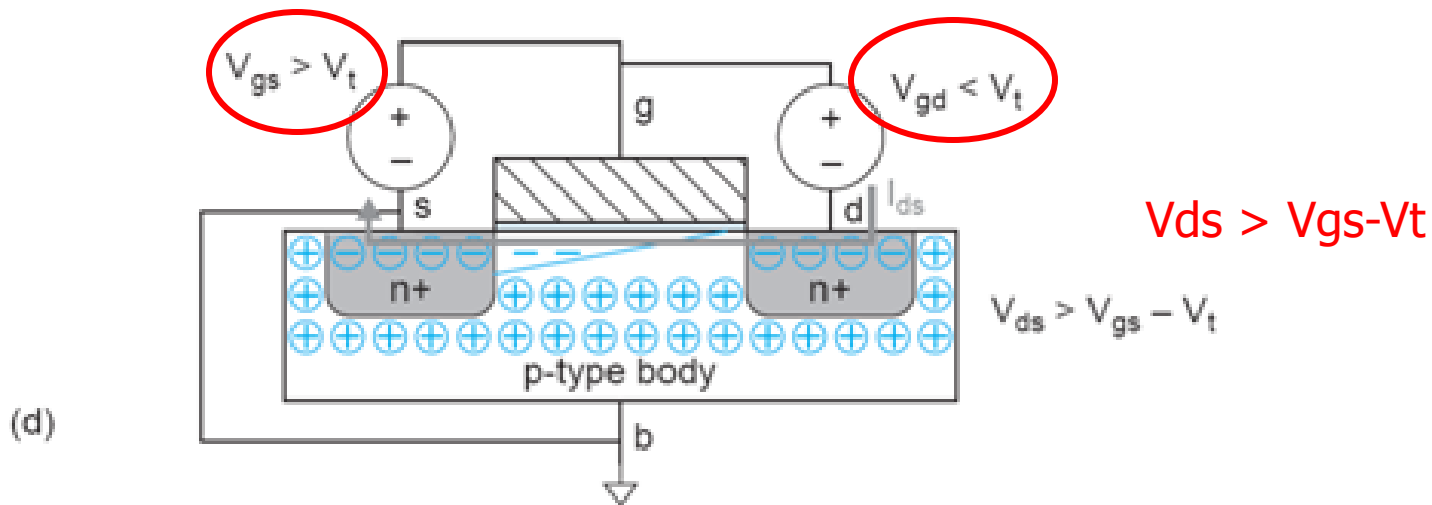
# MOS Operating Regions

- Linear region: channel forms, current flow by drift of electrons (**majority carriers**).

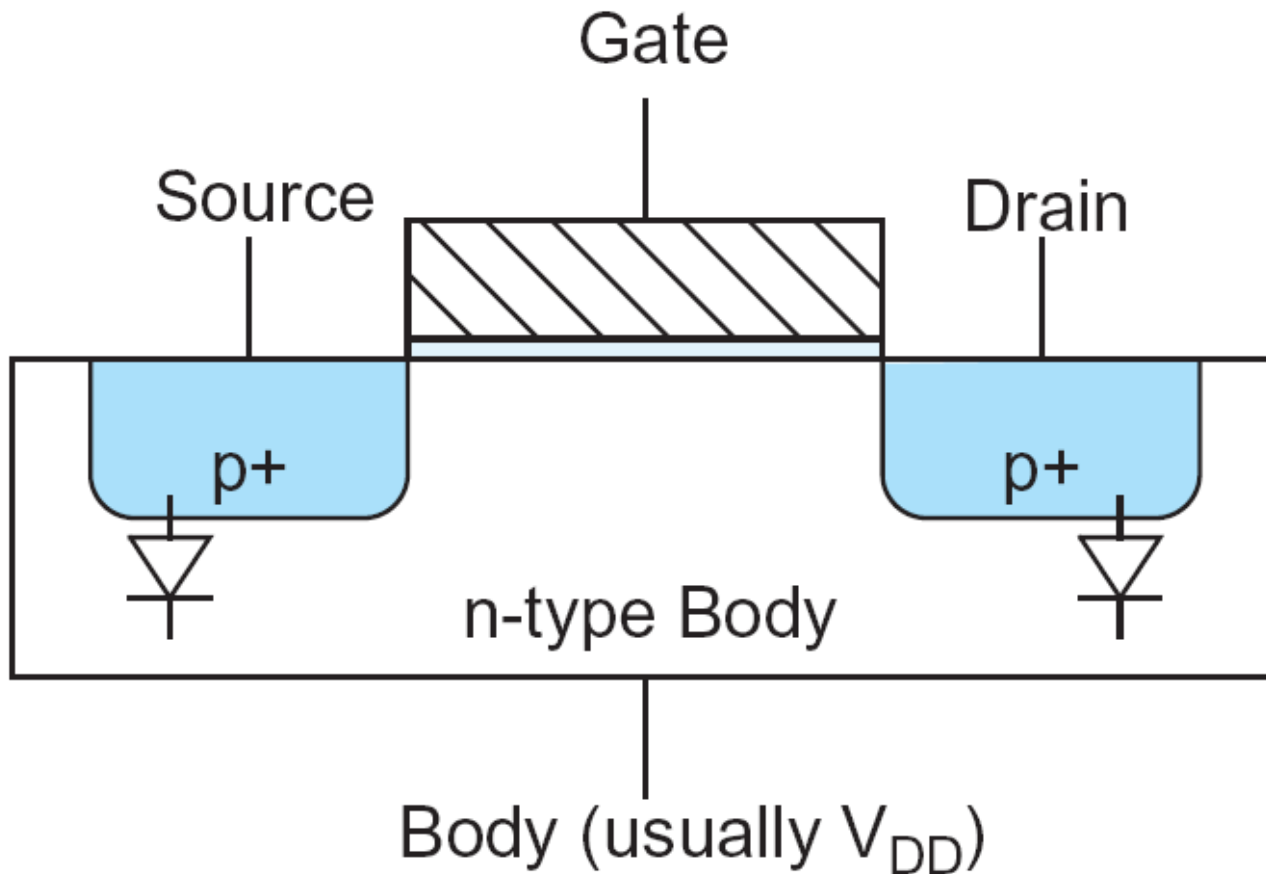


# MOS Operating Regions

- Saturation region: channel pinches off; current independent of  $V_{ds}$ .



# PMOS Transistor



**FIGURE 2.4** pMOS transistor



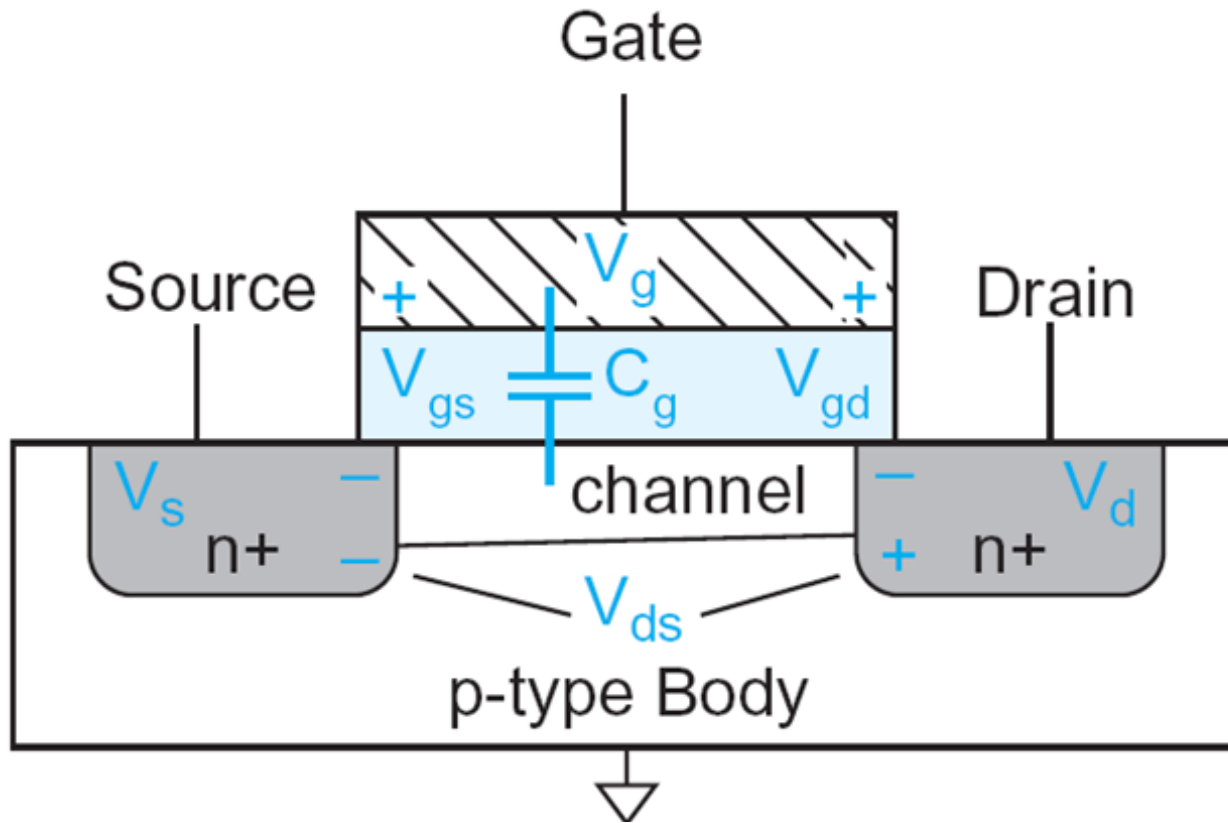
# I-V Characteristics

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- In linear region, MOS transistor has channel inversion and majority carriers conduct current in the form of drifting by electric field.
- Current is then proportional to
  - the amount of charge in the channel, and
  - velocity of carrier movement
- Speed of carriers depends on
  - electric field, and
  - effective mass



# Channel Voltage



Average gate to channel potential:

$$V_{gc} = (V_{gs} + V_{gd})/2 = V_{gs} - V_{ds}/2$$

**FIGURE 2.5** Average gate to channel voltage

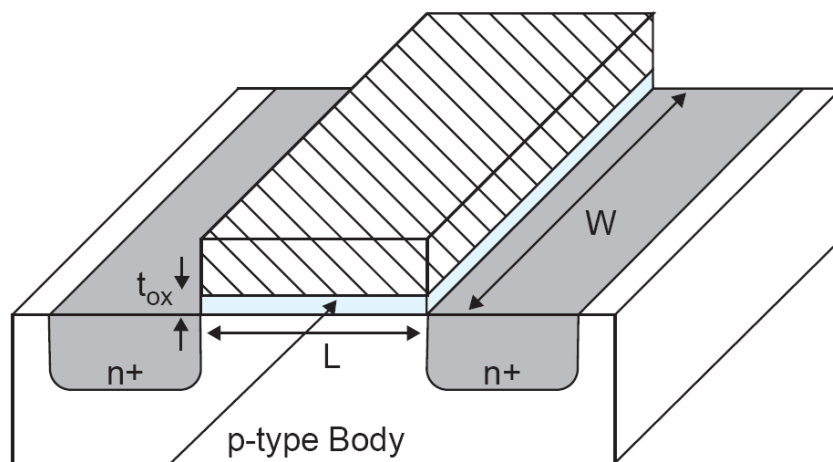
# Channel Charge

- Parallel-plate capacitor

- $Q = C V$

- $C = C_g = \epsilon_{ox} WL / t_{ox} = C_{ox} WL$        $C_{ox} = \epsilon_{ox} / t_{ox}$

- $V = V_{gc} - V_t = V_{gs} - V_{ds}/2 - V_t$



SiO<sub>2</sub> Gate Oxide  
(insulator,  $\epsilon_{ox} = 3.9\epsilon_0$ )

**FIGURE 2.6** Transistor dimensions



# Carrier Velocity

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- Average velocity is related to electric field as

$$v = \mu E,$$

$\mu$  is the mobility of the carrier.

- Electric field is given by

$$E = V_{ds}/L$$

- Time for channel crossing

$$t = L/v$$



# MOS Current in Linear Region

- $I_{ds} = Q/t$

$$= C_{ox}WL(V_{gs}-V_t-V_{ds}/2)/(L/v)$$

$$= C_{ox}WL(V_{gs}-V_t-V_{ds}/2)v/(L)$$

$$= \mu C_{ox}WL(V_{gs}-V_t-V_{ds}/2)V_{ds}/(L^2)$$

$$= \mu C_{ox}(W/L)(V_{gs}-V_t-V_{ds}/2)V_{ds}$$

$$= \beta(V_{gs}-V_t-V_{ds}/2)V_{ds}$$

$$\beta = \mu C_{ox}(W/L)$$



# MOS current in saturation

- When the drain voltage gets higher and  $V_{gd} < V_{t'}$  the channel pinches off.
- When  $V_{ds} > V_{ds(sat)} = V_{gs} - V_{t'}$  the current does not increase as  $V_{ds}$  increases.

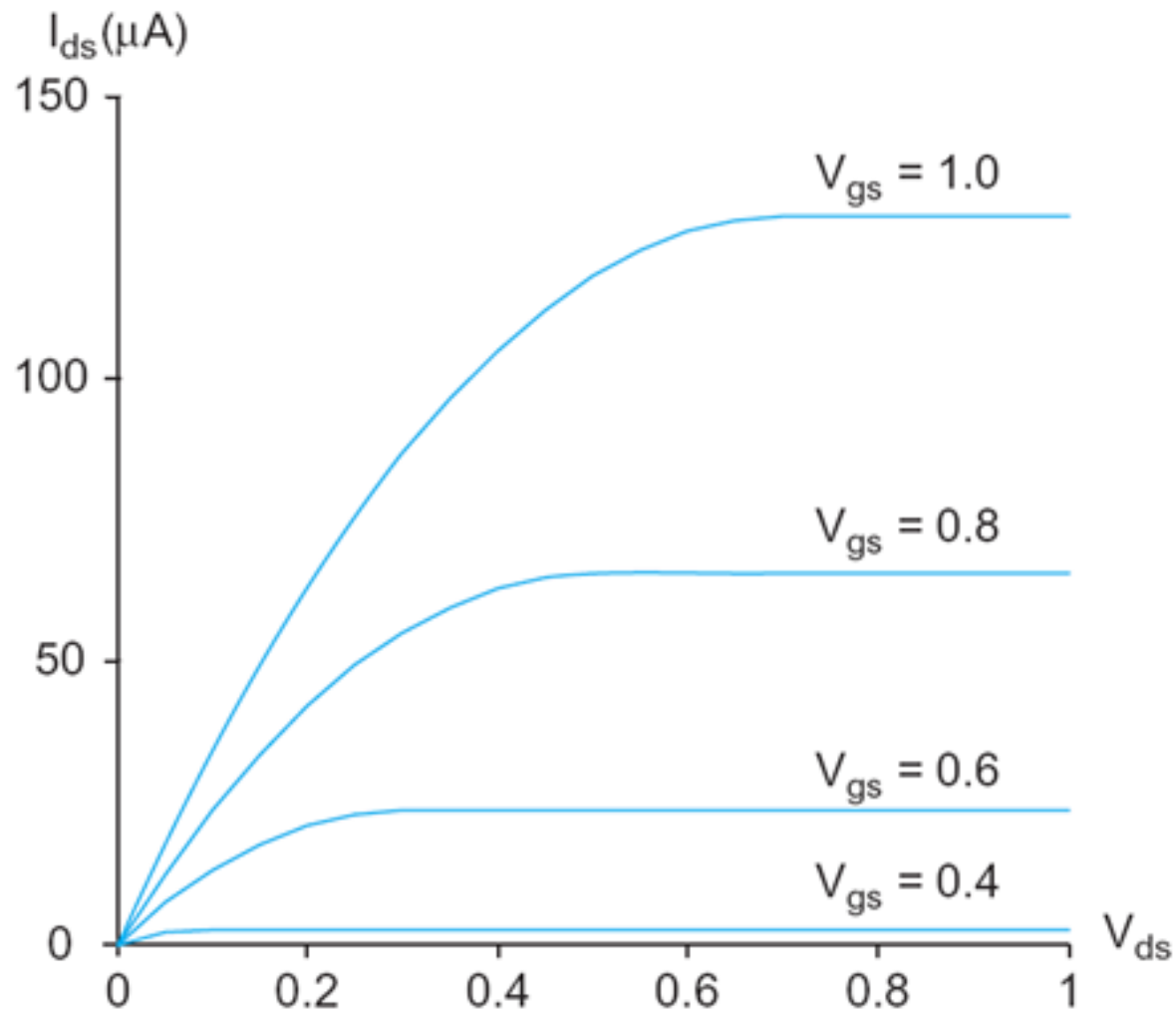
$$\begin{aligned} I_{ds} &= \beta (V_{gs} - V_t - V_{ds(sat)})/2 V_{ds(sat)} \\ &= (\beta/2)(V_{gs} - V_t)^2 \end{aligned}$$



# NMOS I-V Summary

$$I_{ds} = \begin{cases} 0 & V_{gs} < V_t & \text{cutoff} \\ \beta \left( V_{gs} - V_t - \frac{V_{ds}}{2} \right) V_{ds} & V_{ds} < V_{dsat} & \text{linear} \\ \frac{\beta}{2} (V_{gs} - V_t)^2 & V_{ds} > V_{dsat} & \text{saturation} \end{cases}$$

# NMOS I-V Curves





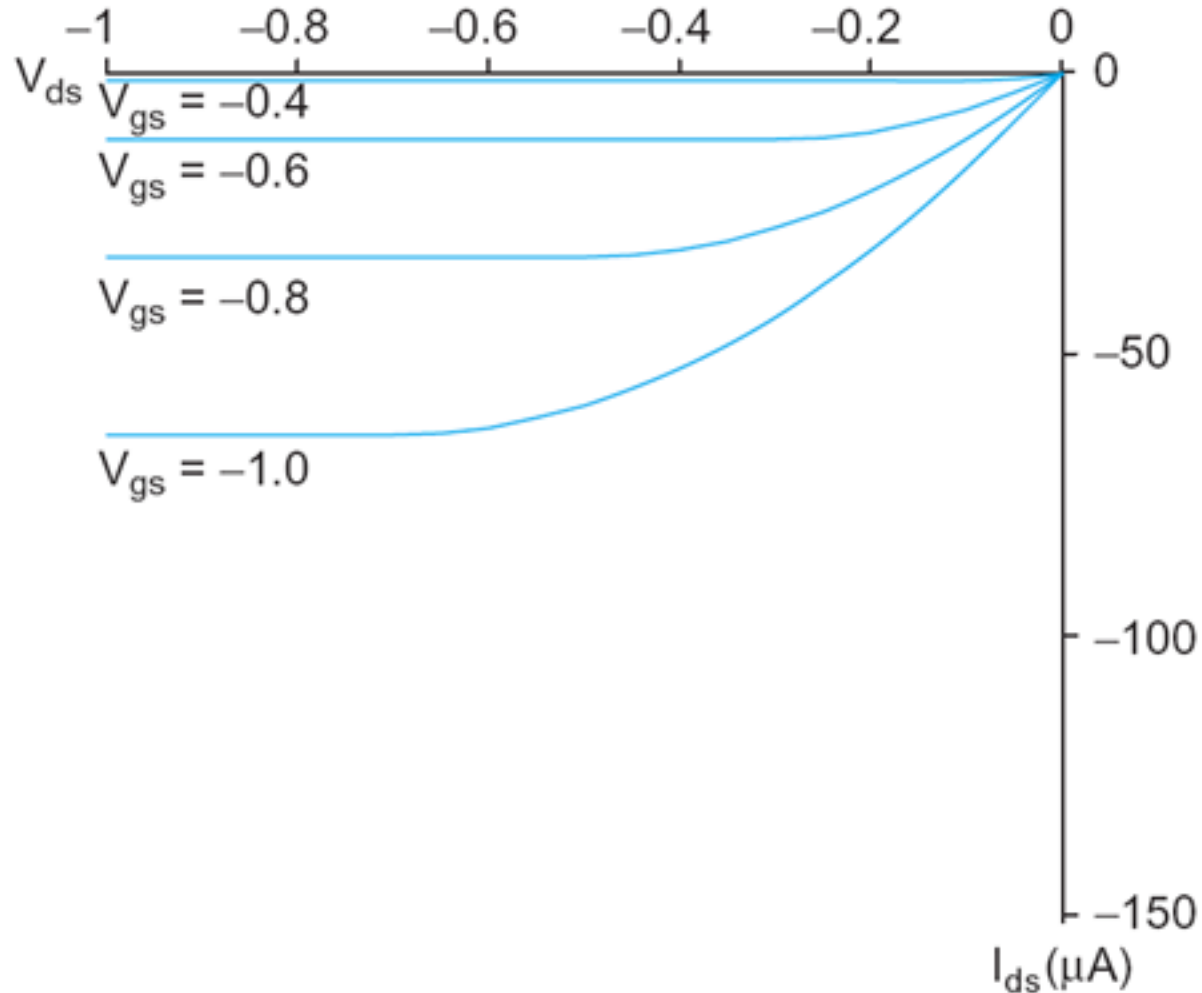
# PMOS Transistor

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- All doping and voltages are inverted
- Mobility is determined by holes, which is about 2-3 times lower than electrons.
- 2X-3X larger ( $W/L$ ) needed for PMOS to achieve same level of current.



# PMOS I-V Curves





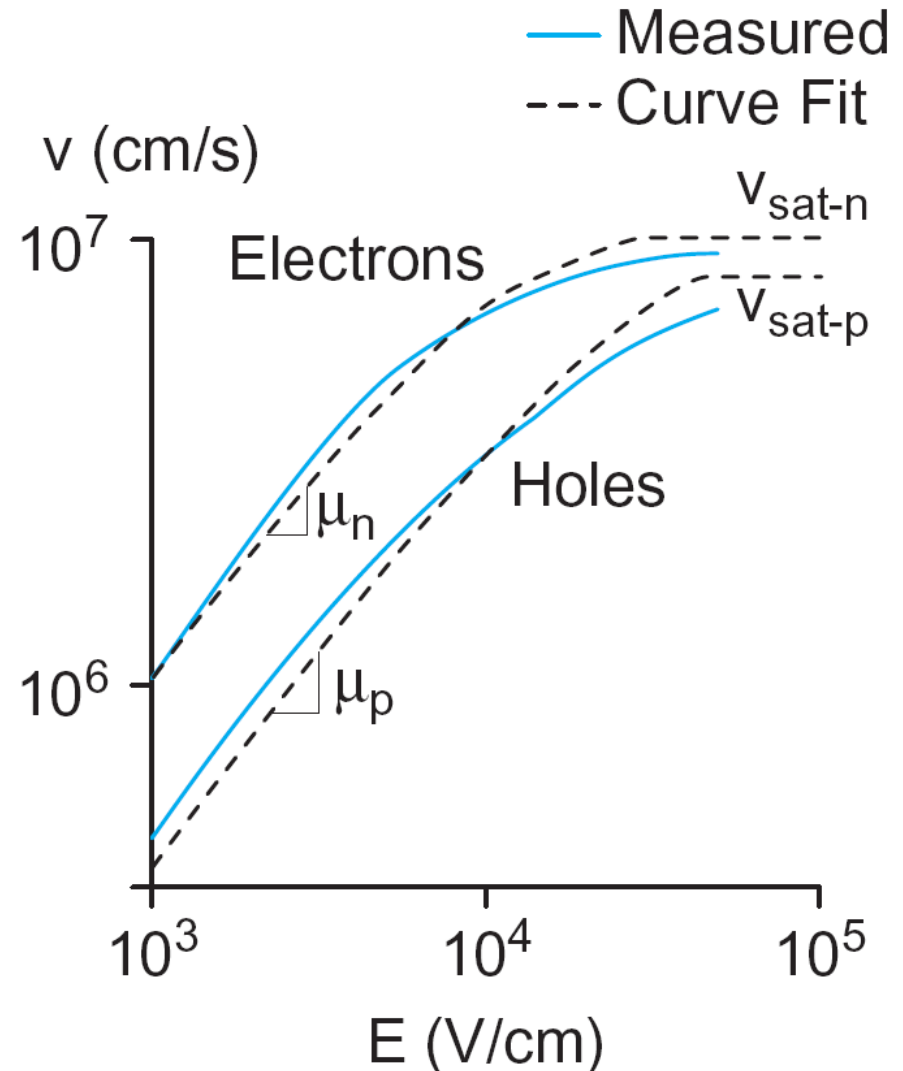
# Non-ideal I-V Effects

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- Velocity Saturation/Mobility Degradation
- Channel Length Modulation
- Body Effect, other  $V_t$  Effects
- Subthreshold Conduction (Channel Leakage)
- Tunneling (Gate Leakage)
- Junction Leakage
- Temperature Dependence

# Velocity Saturation

- The mobility,  $\mu$ , is the ease with which carriers drift in the substrate will cease to scale linearly with electric field ( $E$ ) as it becomes large.





# Mobility Degradation

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- Mobility for electron is greater than that for holes, hence NMOS transistors usually carry larger currents than PMOS ones.
- Mobility decreases as the temperature or the doping concentration increases.
- Mobility also decreases as the vertical electric field ( $V_{gs} - V_t$ ) increases.

# Channel Length Modulation

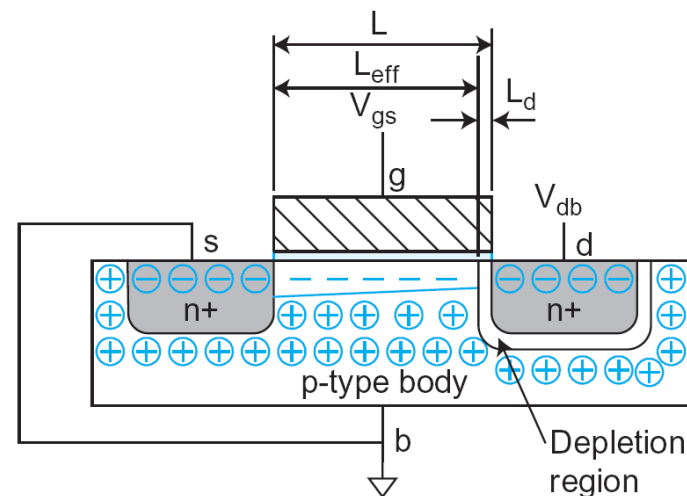
- Higher  $V_{ds}$  shortens the length of the channel due to depletion region around the drain.

$$L_{\text{eff}} = L - L_d$$

- The drain current is affected

$$I_{ds} = \frac{\beta}{2} (V_{gs} - V_t)^2 \left( 1 + \frac{V_{ds}}{V_A} \right)$$

where  $V_A$  is called the Early voltage.



**FIGURE 2.18** Depletion region shortens effective channel length

# Actual I-V Characteristics

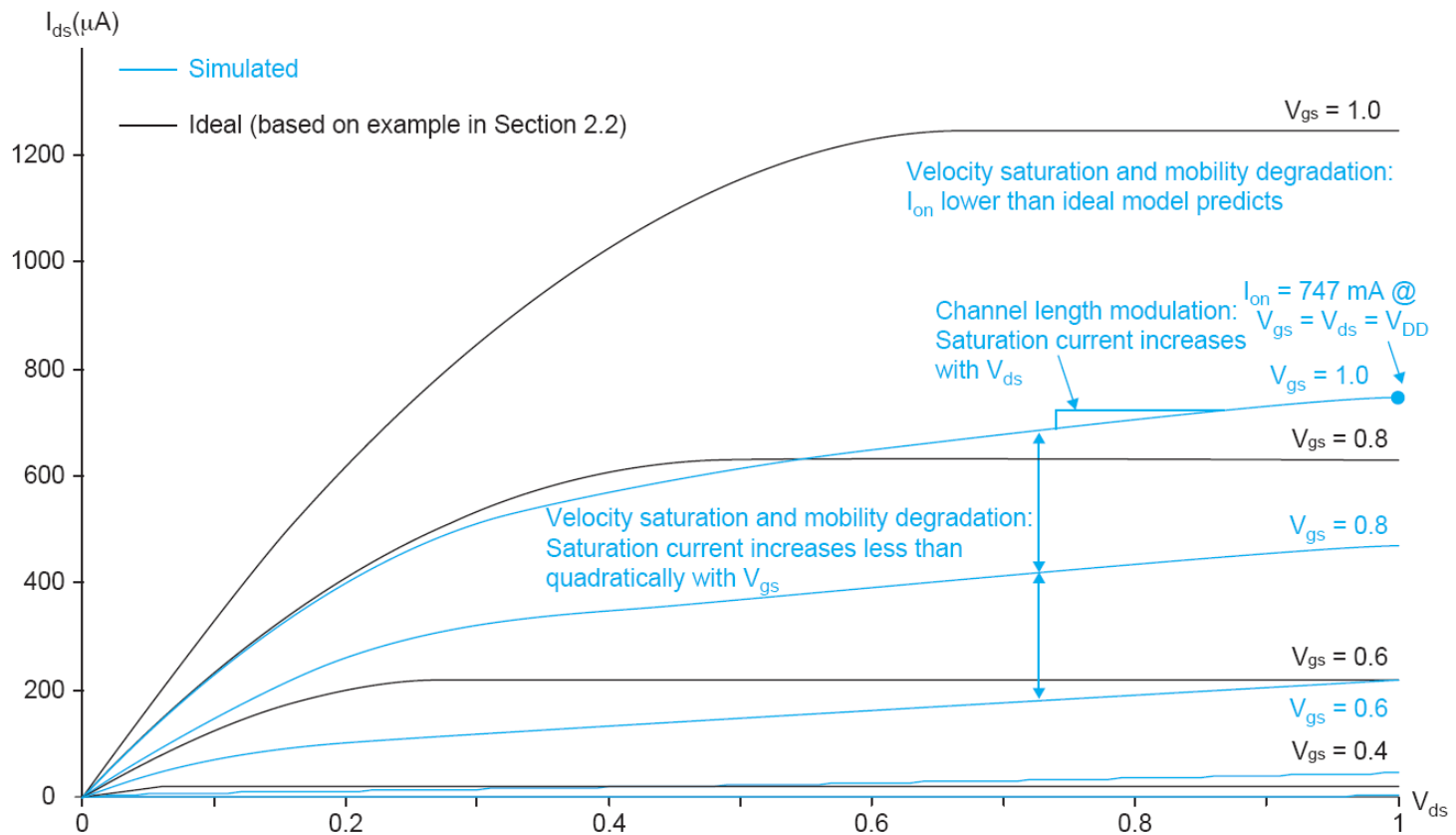


FIGURE 2.14 Simulated and ideal I-V characteristics

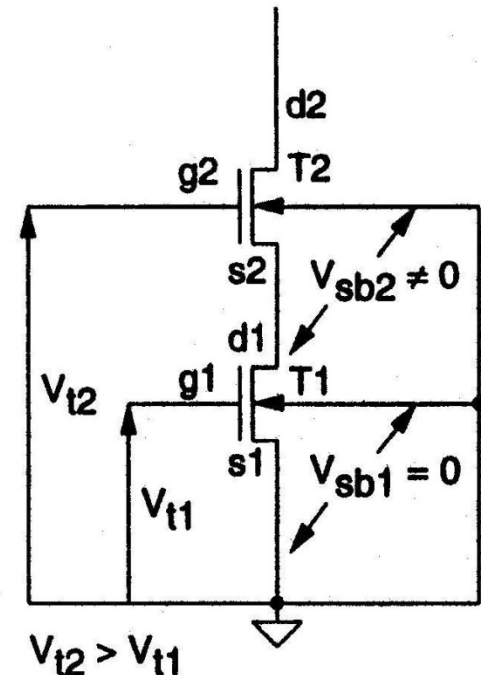
# Body Effect

- Body is the fourth terminal of an MOS transistor
- An effect that influences the threshold voltage is the **body effect**, which is caused by nonzero source to bulk (substrate) voltage ( $V_{sb}$ )

$$V_t = V_{t0} + \gamma \left( \sqrt{\phi_s + V_{sb}} - \sqrt{\phi_s} \right)$$

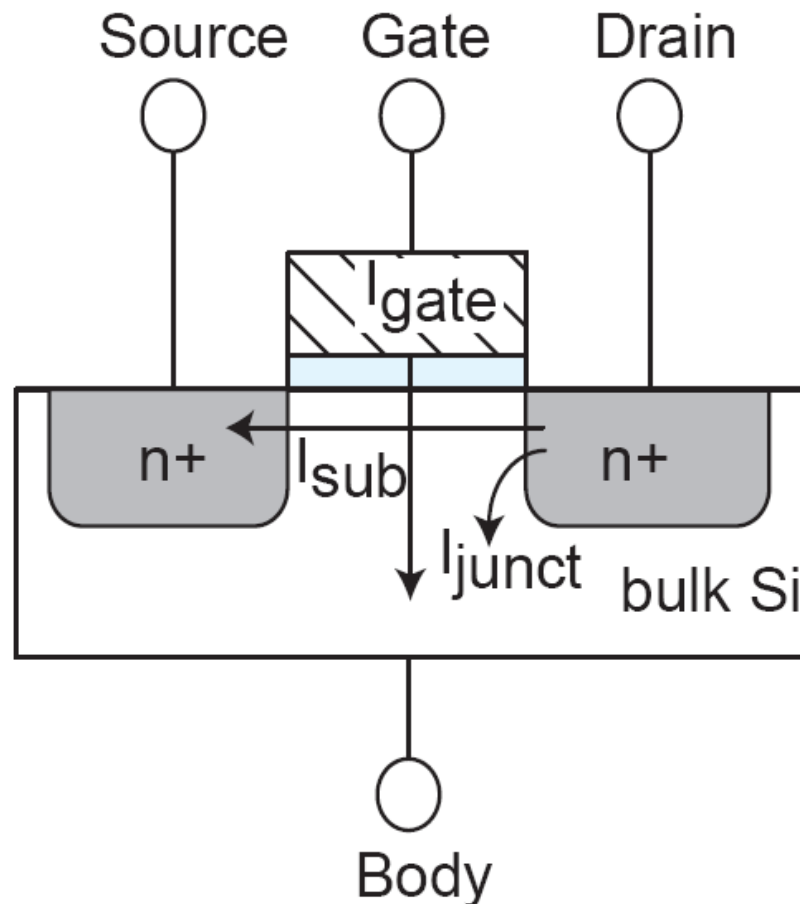
where  $\gamma$  is the body effect coefficient.

- For example, nonzero  $V_{sb2}$  makes  $V_{t2} > V_{t1}$ .



# Leakage

- Three different paths



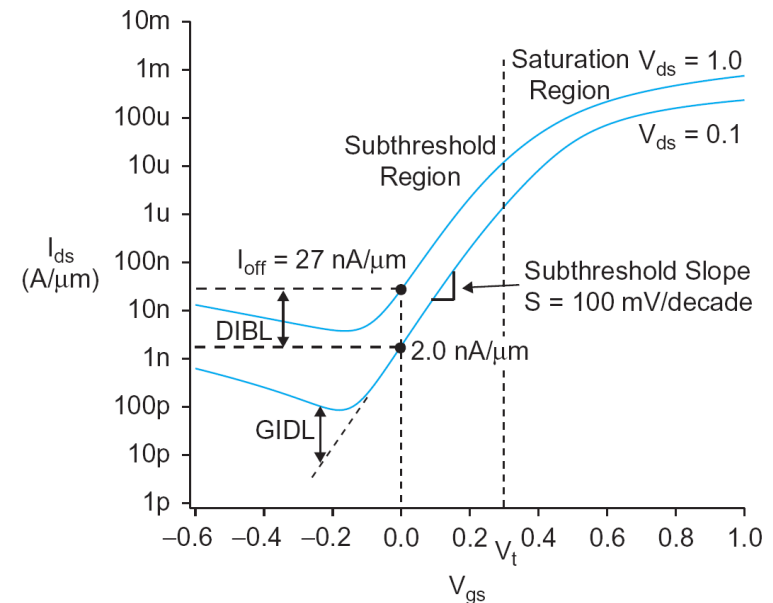


# Subthreshold Conduction

- MOS transistors in the cutoff region actually conduct current except that the current is very small (on the order of  $10^{-6}$  to  $10^{-11}$ A) . So this region should be named **subthreshold region** ( $V_{gs} < V_t$ ), and in this region the drain current depends exponentially on  $V_{gs}$

$$I_{ds} = I_{ds0} e^{\frac{V_{gs} - V_t}{n v_T}} \left( 1 - e^{-\frac{V_{ds}}{v_T}} \right)$$

- $v_T$  is the thermal voltage and is 26mV at room temperature.  $V_t$  can be modified by body effect and DIBL effect.



**FIGURE 2.20** I-V characteristics of a 65 nm nMOS transistor at 70 °C on a log scale



# Channel Leakage

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- This current is also considered leakage current.
- As  $V_t$  becomes smaller in advanced technology subthreshold conduction becomes a major problem in power consumption since it seems that all open switches in a digital IC are leaking and there are billions of such switches.
- Some technology offers option to increase  $V_t$  of selected transistors to reduce such leakage using another mask.



# Tunneling

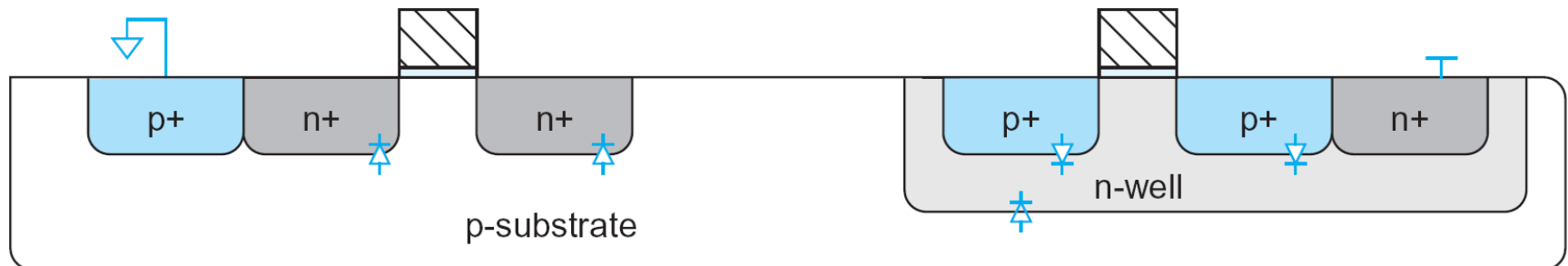
- When the gate oxide is very thin, quantum mechanics predicts that current can flow across the gate oxide by electron tunneling, causing **gate leakage**. **Direct tunneling** (low V) and **FN tunneling** (high V)
- For gate oxide thinner than 15-20 angstrom, tunneling current may become comparable to subthreshold leakage.
- To achieve high  $C_{ox}$  without using very thin insulator, new material with higher dielectric constant ( $k$ ), e.g.  $Si_3N_4$ , has been used.
- Electrically programmable circuits, e.g., EEPROM and flash memory employ this tunneling to transport charges to and from otherwise isolated regions.

# Junction Leakage

- MOS transistors are protected by depletion region formed through reversed biased diodes with leakage current.

$$I_D = I_S \left( e^{\frac{V_D}{v_T}} - 1 \right)$$

- This leakage has been limiting factor for node voltage storage and is now overwhelmed by subthreshold conduction due to lower threshold voltage.

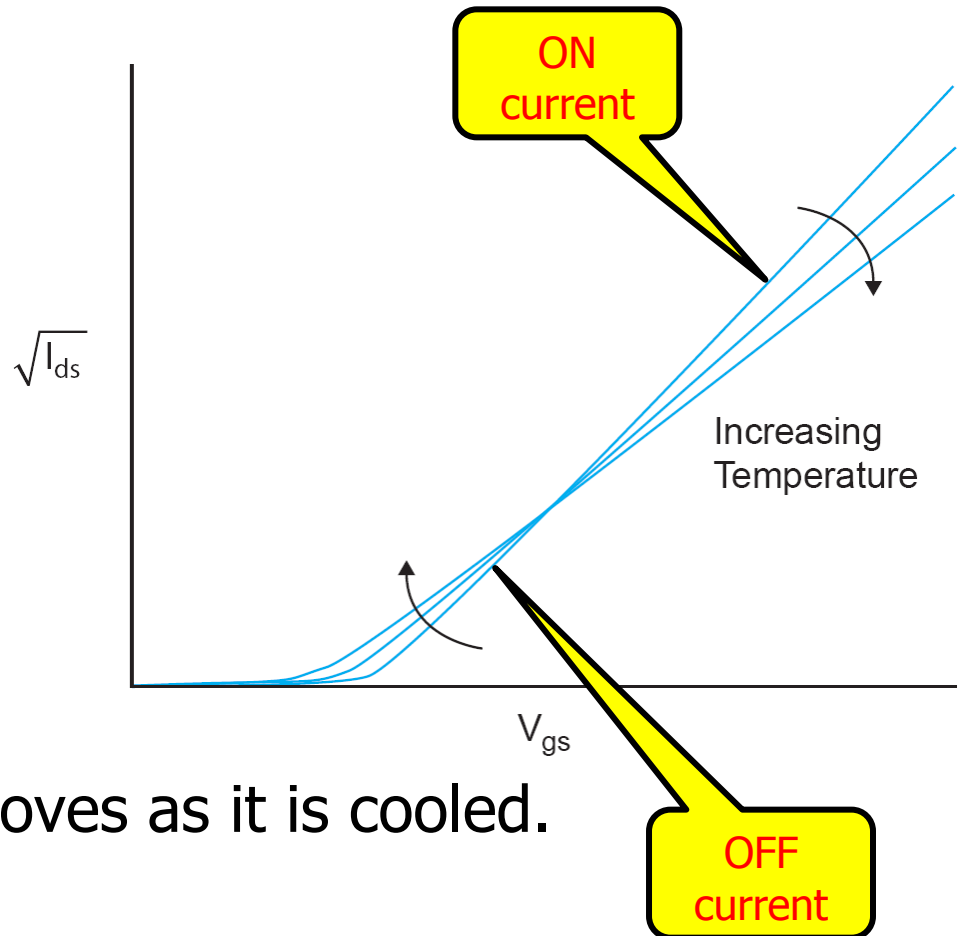


# Temperature Dependence

- Many MOS characteristics are influenced by temperature.

- As  $T \uparrow$

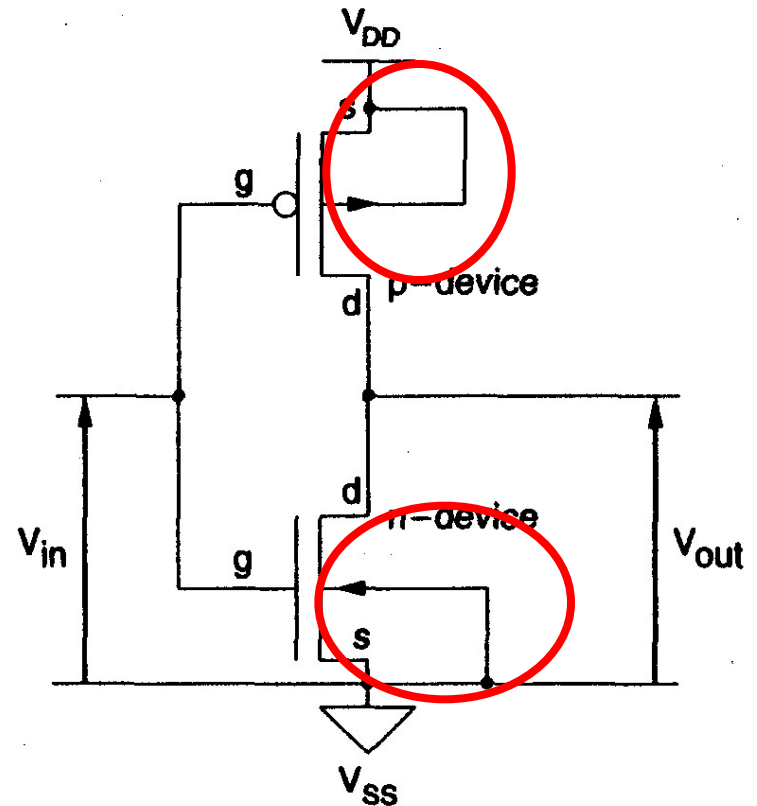
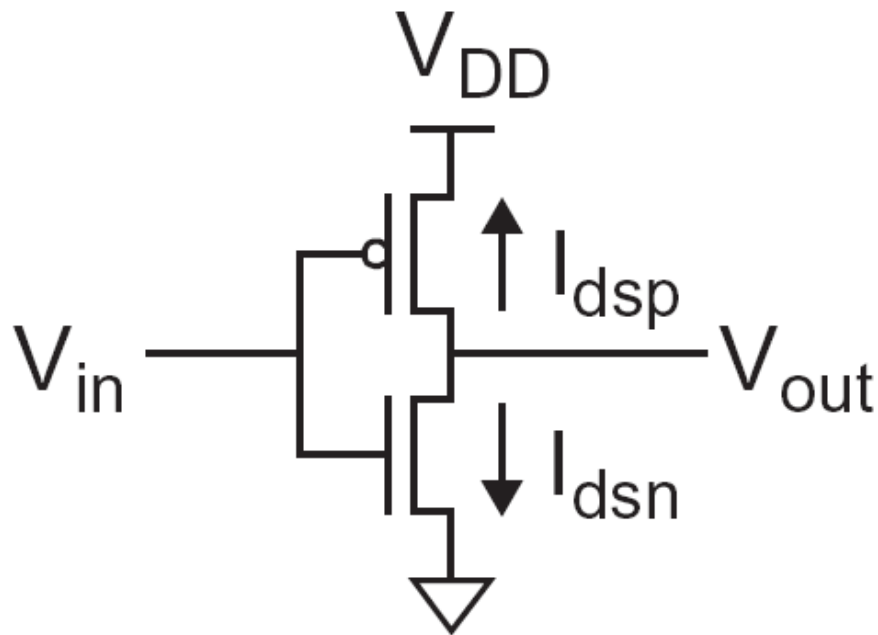
- Mobility  $\downarrow$
- Threshold voltage  $\downarrow$
- Junction leakage  $\uparrow$
- Subthreshold leakage  $\uparrow$
- OFF current  $\uparrow$
- ON current  $\downarrow$



- Circuit performance improves as it is cooled.

# CMOS Inverter

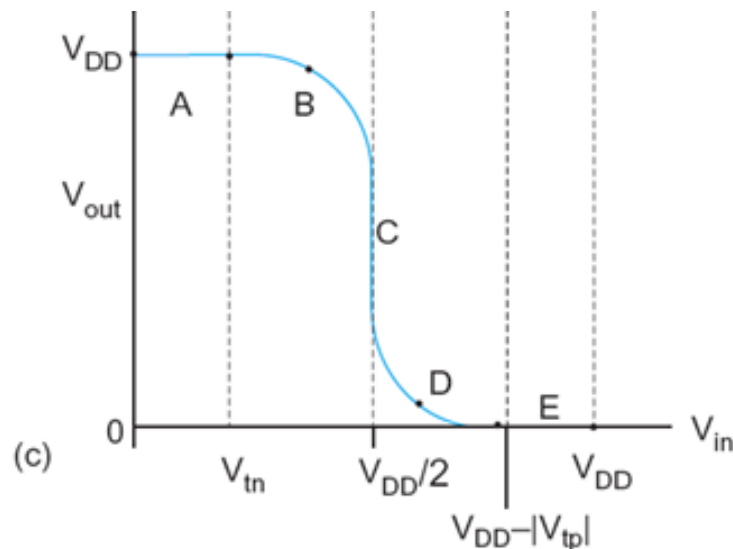
- One NMOS and one PMOS in series, both gates being controlled by the input.



# Five Regions

**Table 2.3** Summary of CMOS inverter operation

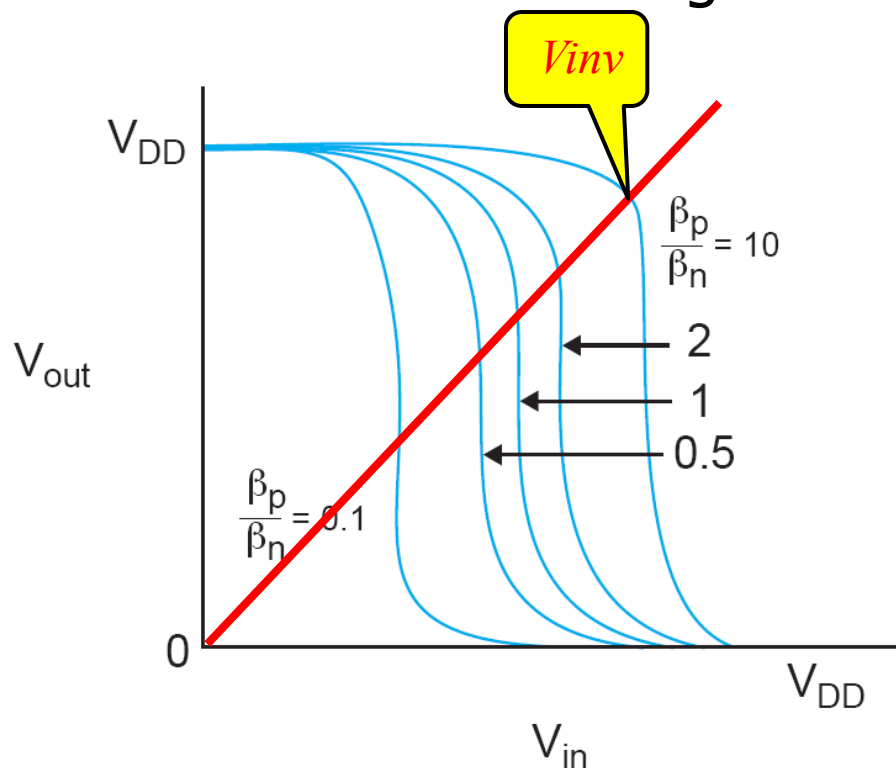
Region	Condition	p-device	n-device	Output
A	$0 \leq V_{in} < V_{tn}$	linear	cutoff	$V_{out} = V_{DD}$
B	$V_{tn} \leq V_{in} < V_{DD}/2$	linear	saturated	$V_{out} > V_{DD}/2$
C	$V_{in} = V_{DD}/2$	saturated	saturated	$V_{out}$ drops sharply
D	$V_{DD}/2 < V_{in} \leq V_{DD} -  V_{tp} $	saturated	linear	$V_{out} < V_{DD}/2$
E	$V_{in} > V_{DD} -  V_{tp} $	cutoff	linear	$V_{out} = 0$



# NMOS/PMOS Size ratio

- The gate threshold voltage,  $V_{inv}$ , where  $V_{in} = V_{out}$  is controlled by the  $\beta_n/\beta_p$  ratio. For a  $\beta_n/\beta_p$  ratio of one, the inverter has the same current sourcing and sinking capability, i.e., the NMOS transistor is as strong as the PMOS transistor.

$$\beta_n = \frac{\mu_n \epsilon}{t_{ox}} \left( \frac{W_n}{L_n} \right) \quad \beta_p = \frac{\mu_p \epsilon}{t_{ox}} \left( \frac{W_p}{L_p} \right)$$



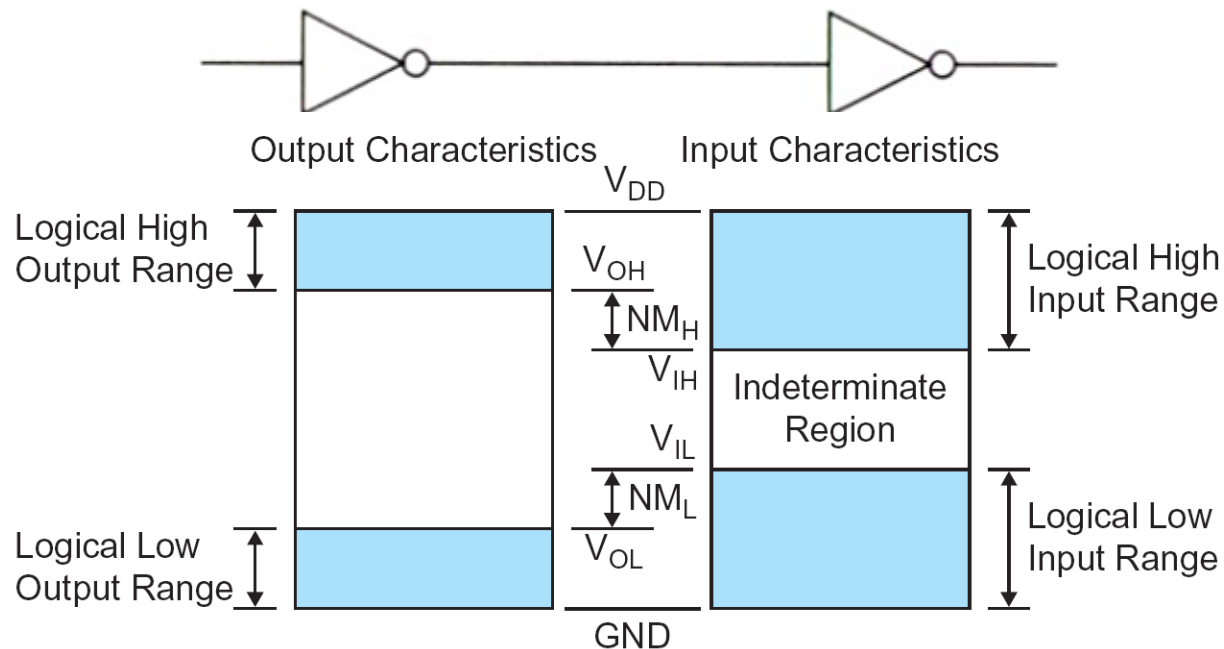


# Noise Margin

- Noise margin is the margin of noise that can be inflicted on a gate output before it wrongly switches the next-stage circuit.

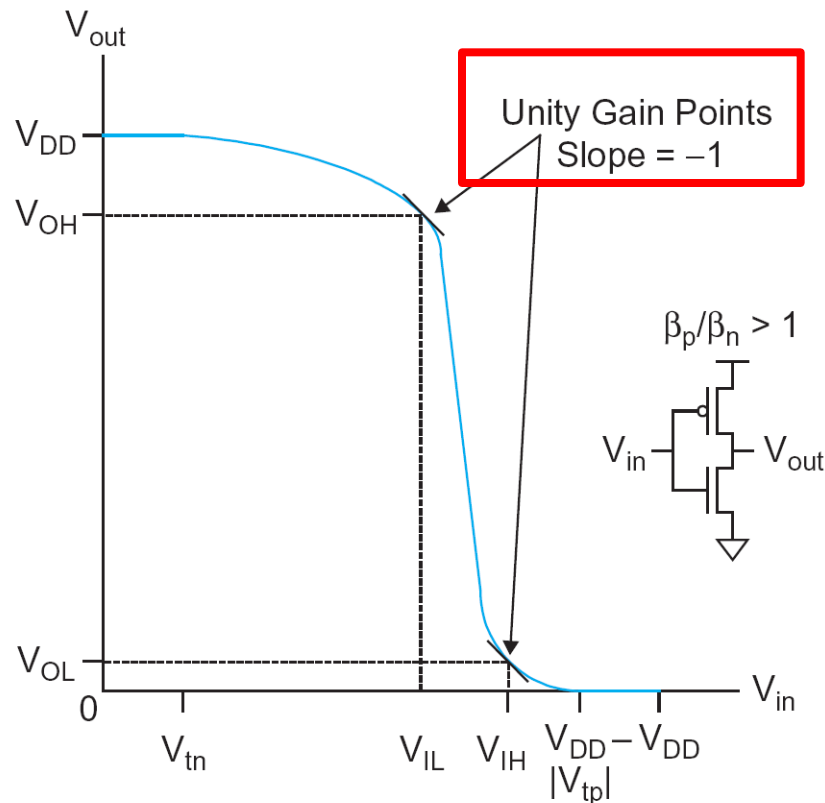
$$NM_L = V_{IL} - V_{OL} \quad NM_H = V_{OH} - V_{IH}$$

$V_{IH}$  = minimum HIGH input voltage  
 $V_{IL}$  = maximum LOW input voltage  
 $V_{OH}$  = minimum HIGH output voltage  
 $V_{OL}$  = maximum LOW output voltage.



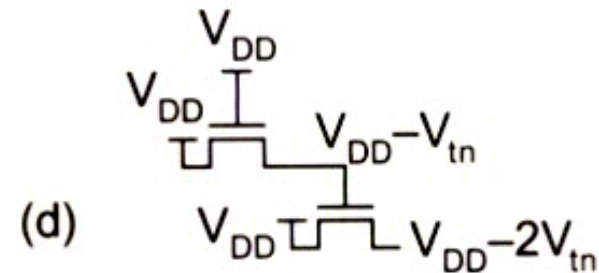
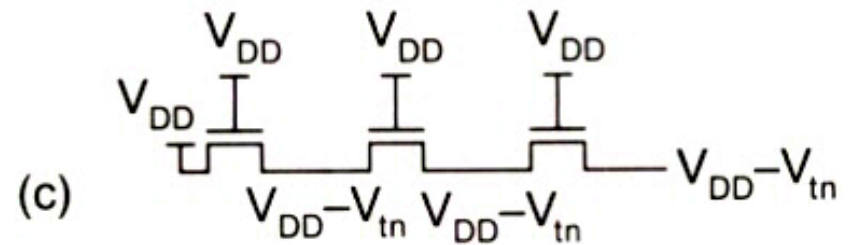
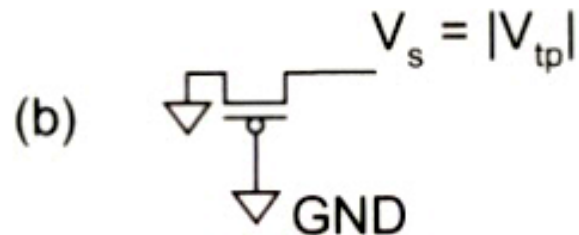
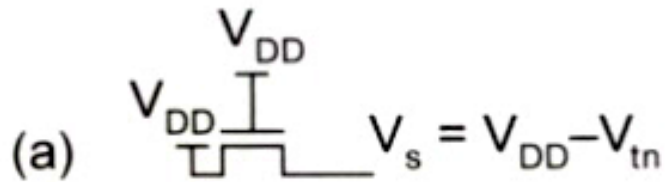
# Noise Margin (cont'd)

- The determination of  $V_{IH}$ ,  $V_{IL}$ ,  $V_{OH}$ ,  $V_{OL}$  is achieved by locating the two unity gain points (slope = -1) in the transfer characteristic of the inverter.



# Pass Transistor

- Threshold drop





# CMOS Layout Video

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- <https://www.youtube.com/watch?v=S6-3fMIdoa8>



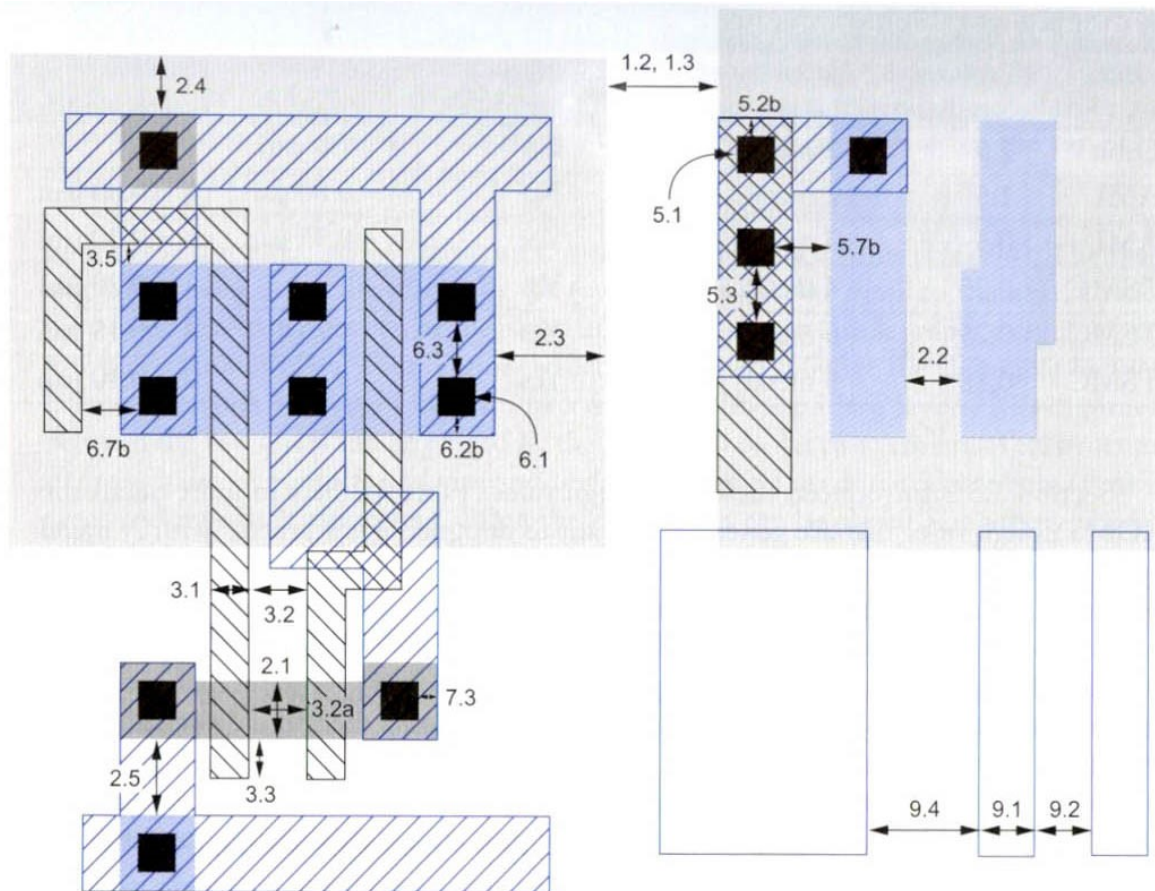
# Design Rules

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- Rules that specify some limitation on the precision of IC fabrication.
- Compromise between performance and yield.
- Represent a tolerance that ensures very high probability of correct fabrication.
- A layout violating some rules can still work, and vice versa.
- $\lambda$  rules and  $\mu$  rules.  $\lambda$  rules are more conservative.

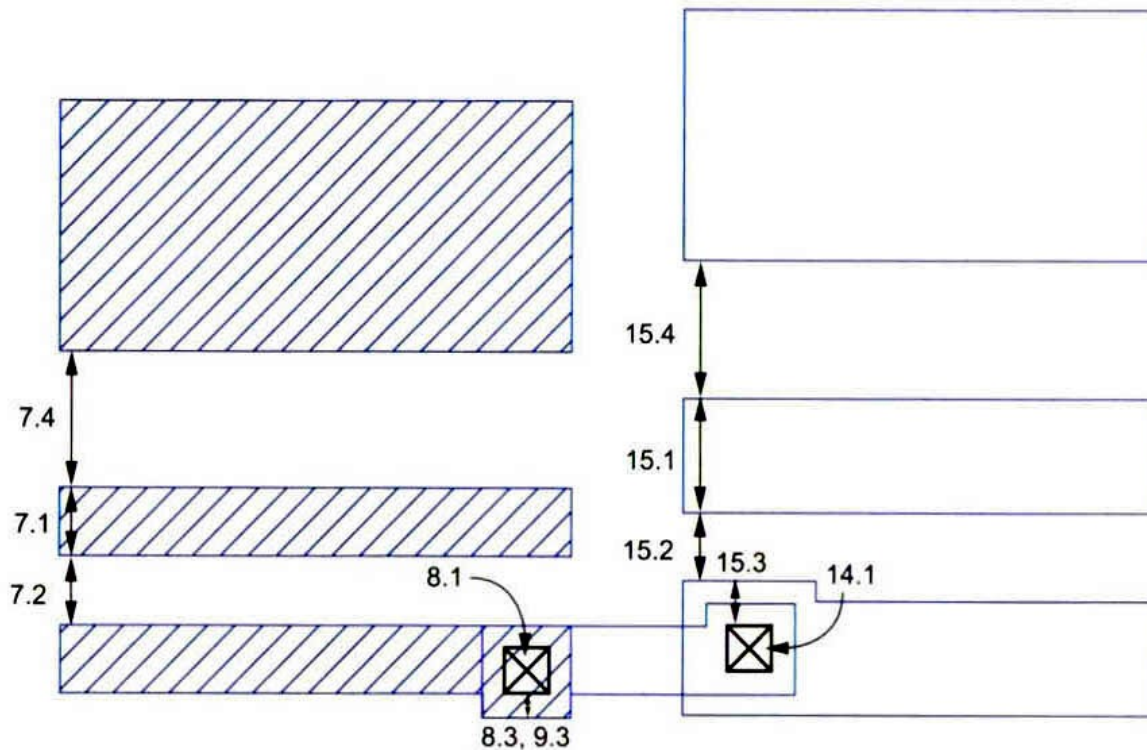
# Layout Design Rules

- Design rules are rules on the width, spacing, extension, overlap of the same layer or between different layers.



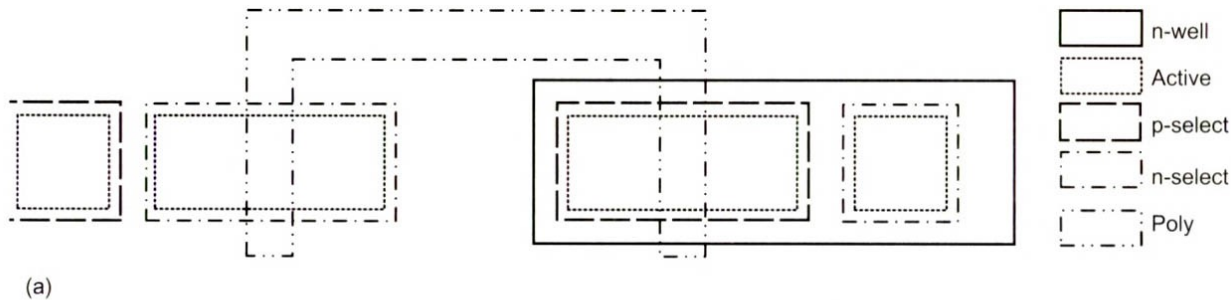
# More Design Rules

- Rules for Metal 1 and Metal 3.

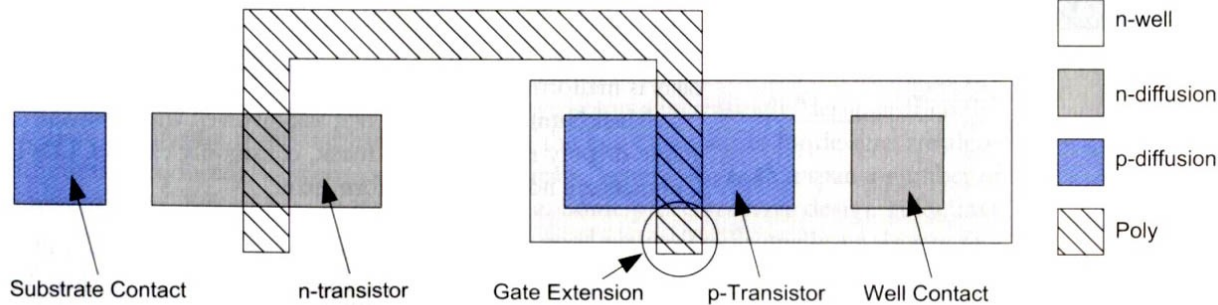


# Design Rule Background

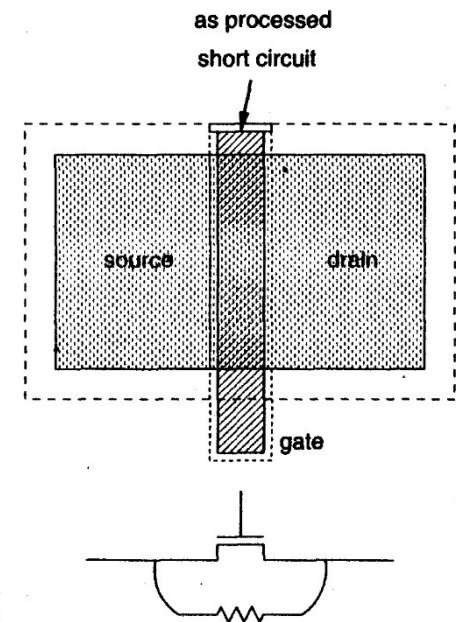
- Well rules -- Outside clearance is due to lateral diffusion. Inside clearance is to prevent bird's beak produced by field oxide encroachment.
- Transistor rules -- to prevent short-circuited MOS



(a)



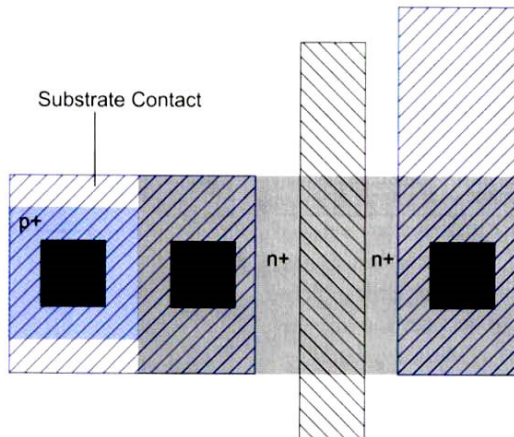
(b)



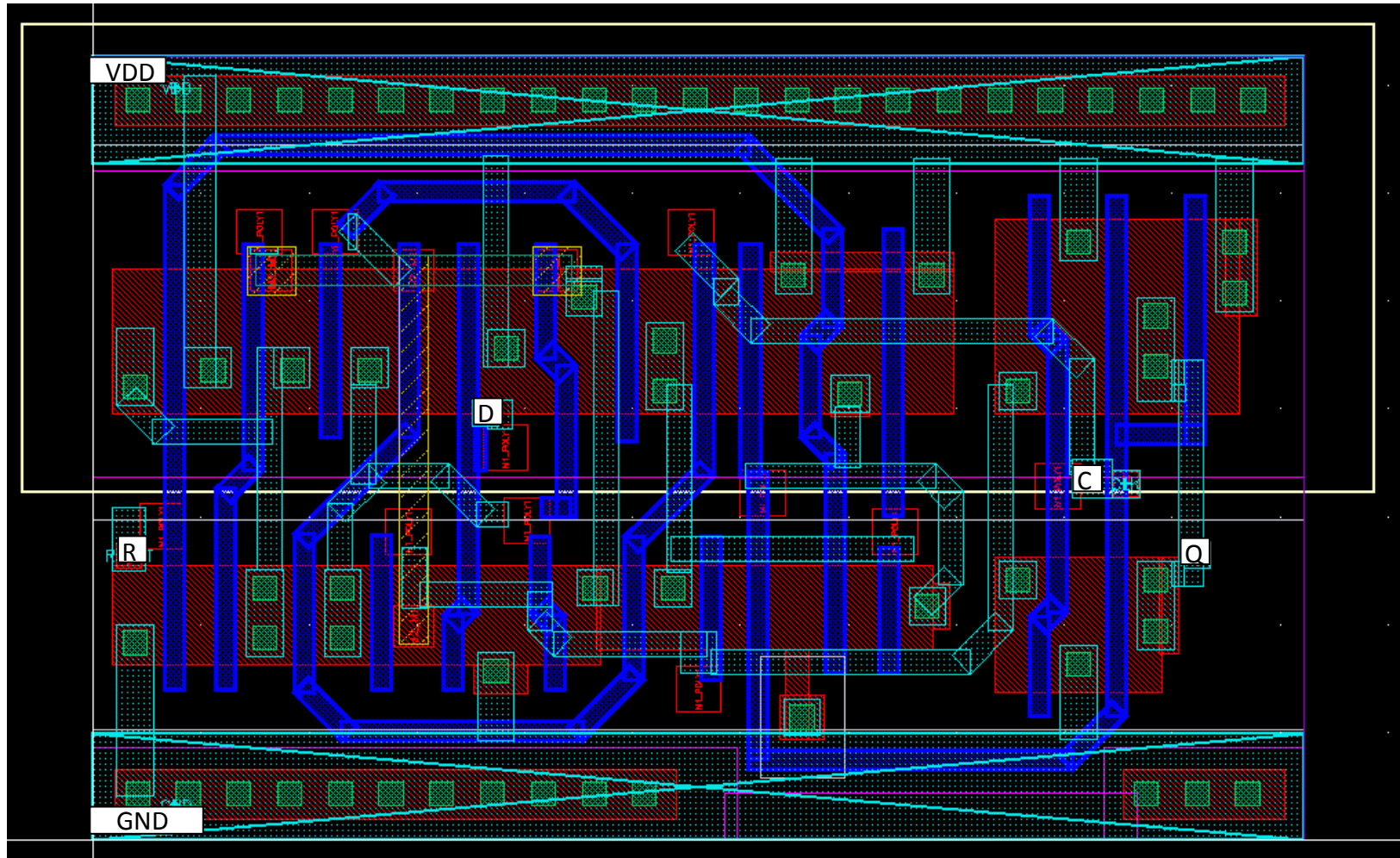


# Contact/Metal/Via Rules

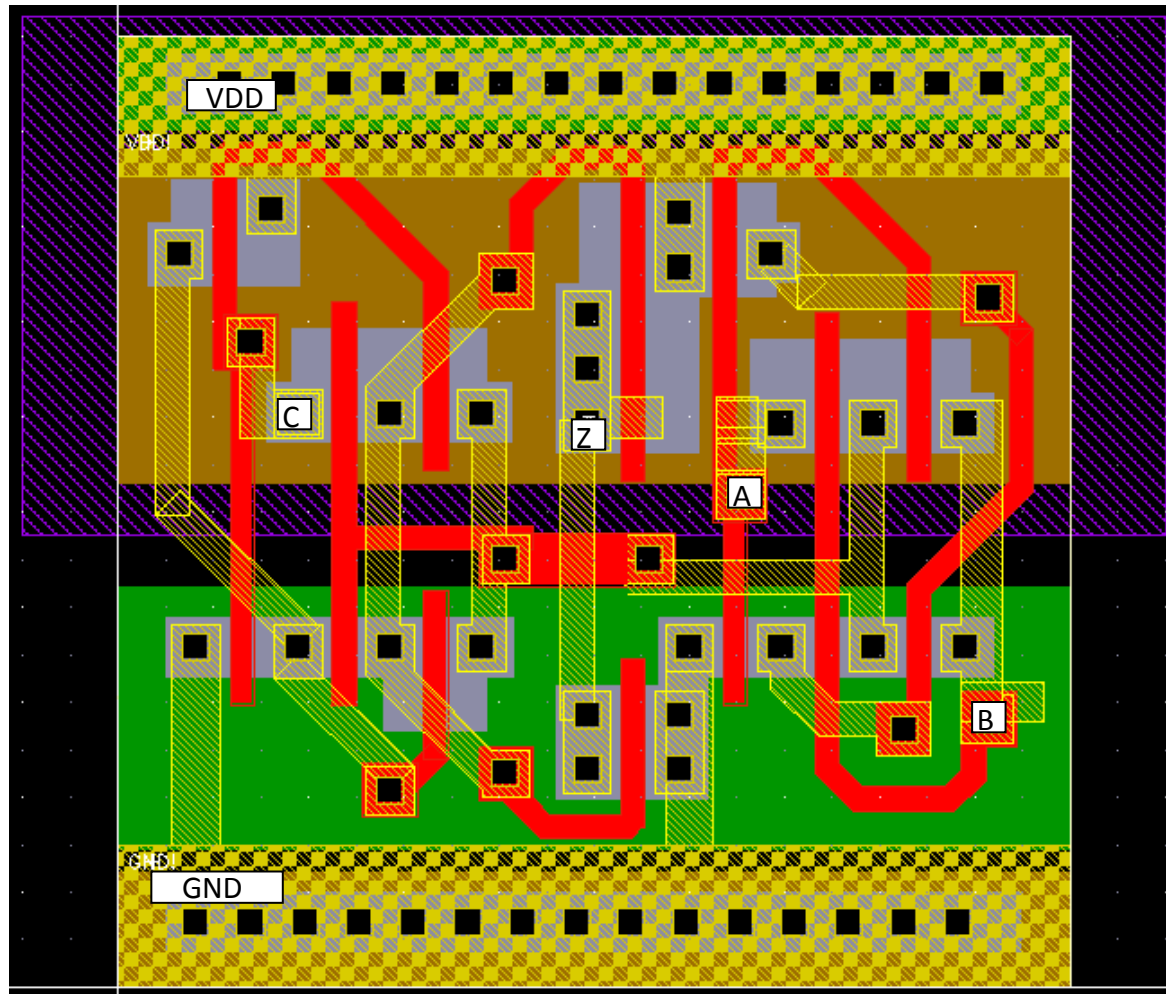
- Contacts from metal to diffusion, poly, well, substrate. Uniform sized squares. As many as possible.
- Metal spacing increases as metal width and thickness.
- Stacked via (between metals) can save area, but no straddling boundary of lower-level contact edges.



# D-FF Layout



# Full Adder Layout (Partial)



# A micron rule set

Table 3.3 Micron design rules for 65nm process			
Layer	Rule	Description	65 nm rule (μm)
Well	1.1	Width	0.5
	1.2	Spacing to well at different potential	0.7
	1.3	Spacing to well at same potential	0.7
Active (diffusion)	2.1	Width	0.10
	2.2	Spacing to active	0.12
	2.3	Source/drain surround by well	0.15
	2.4	Substrate/well contact surround by well	0.15
	2.5	Spacing to active of opposite type	0.25
Poly	3.1	Width	0.065
	3.2	Spacing to poly over field oxide	0.10
	3.2a	Spacing to poly over active	0.10
	3.3	Gate extension beyond active	0.10
	3.4	Active extension beyond poly	0.10
	3.5	Spacing of poly to active	0.07
Select	4.1	Spacing from substrate/well contact to gate	0.15
	4.2	Overlap of active	0.12
	4.3	Overlap of substrate/well contact	0.12
	4.4	Spacing to select	0.20
Contact (to poly or active)	5.1, 6.1	Width (exact)	0.08
	5.2b, 6.2b	Overlap by poly or active	0.01
	5.3, 6.3	Spacing to contact	0.10
	5.4	Spacing to gate	0.07
Metal1	7.1	Width	0.09
	7.2	Spacing to well metal1	0.09
	7.3, 8.3	Overlap of contact or via	0.01
	7.4	Spacing to metal for lines wider than 0.5 μm	0.30
Via1-Via5	8.1, 14.1, ...	Width (exact)	0.10
	8.2, 14.2, ...	Spacing to via on same layer	0.10



# Enhanced Features in New Process

- Multiple thresholds
  - Low  $V_t$  transistors on critical circuits; high  $V_t$  transistors elsewhere.
- Thicker oxide – for I/O transistors; 3.3V for I/O, 1.8V for core.
- High-k gate dielectric –  $\text{HfO}_2$  ( $k=20$ ),  $\text{ZrO}_2$  ( $k=23$ )  
 $\text{Si}_3\text{N}_4$  ( $k=6.5-7.5$ )
  - increase the  $\epsilon$  ( $k$ ) of the gate insulator to get more current
- FinFET (3D transistor)

# FinFET

- 3D Transistor (Intel version):

<https://www.youtube.com/watch?v=oWSPDoIEyfs>

<http://www.youtube.com/watch?v=C6Rhxfmlpg>

